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Docket No.: 1315-050

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Inventor(s): Byoung Kee KIM et al.

Confirmation No.1579

U.S. Patent Application No. 10/747,657

: Group Art Unit: 1742

Filed: December 30, 2003

Examiner: Mai, Ngoclan Thi

For:

PROCESS FOR MANUFACTURING ULTRA FINE TIC-TRANSITION METAL

BASED COMPLEX POWDER

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of the first Office Action on the merits, but before the mailing date of the Final Rejection or Notice of Allowance.

86/28/2005 TL0111 00000003 10747657

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CERTIFICATION OF FACSIMILE TRANSMISSION I HEREBY CERTIFY THAT THIS PAPER IS BEING FACSIMI-

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A credit card authorization form in the amount of \$180.00 is attached. Any deficiency or overpayment should be charged or credited to Deposit Account No. 07-1337.

Respectfully submitted,

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Date: June 27, 2005

Sheet 1 of 1

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)			APPLICANT Byoung Kee KIM et al.			TION NO.	
			FILING DATE December 30, 2003		GROUP 1742		
		U.S. PATENT I	OCUMENTS	in State			
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	SUBCLASS DATE	
	US-2002/0043130	04-2002	Kim et al.				
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		FOREIGN PATEN	T DOCUMENTS	<u> </u>			
EXAMINER'S PATENT NO DATE			COUNTRY CLASS		SUBCLASS Translation		
INITIALS				02.00	50202.50	Yes	No
						<u> </u>	
1	OTHER	ART (Including Author, 7	Γitle, Date, Pertinent	Pages, Etc	<u> </u>		
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EXAMINER	DATE CONSIDERED						

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.